

Notice of References Cited

Application/Control No.

09/782,185

Applicant(s)/Patent Under

Reexamination

ZHU ET AL.

Examiner

Kin-Chan Chen

Art Unit

1765

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Plummer et al. " Silicon VLSI Technology", Prentice Hall, 2000, page 639.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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